



Response Under 37 C.F.R. § 1.114
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 In re application of:) Docket No: LAM1P077A
Kuthi, et al.)
Application No: 09/611,037) Group Art Unit: 1763 #1386 12/8/02 MW
10 Filed: July 6, 2000) Examiner: Alejandro, L.
For: METHOD FOR IMPLEMENTING A) Date: November 22, 2002
SEMICONDUCTOR PROCESS)
15 CHAMBER ELECTRODE (as amended))

CERTIFICATE OF MAILING:

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington DC 20231 on November 22, 2002.

Signed: _____

Neely J. Weldy

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

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Dear Sir:

Applicants submit this Amendment in response to the Final Office Action dated July 25, 2002. The period for response extends to October 25, 2002. A one month extension of time is hereby petitioned for to extend the period of response to November 25, 2002. Please enter the following amendments and remarks:

IN THE TITLE

40 Please amend the title to --METHOD FOR IMPLEMENTING A
SEMICONDUCTOR PROCESS CHAMBER ELECTRODE--.

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